

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT APPLICATION**

In re Application of:

Tran et al.	Atty. Docket: TI-37297
Serial No.: TBD	Art Unit: TBD
Filed: Herewith	Examiner: TBD
For: AN IMPROVED CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS	

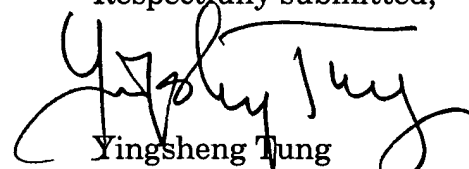
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97 & 1.98

Sir:

Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO-1449. Pursuant to the new rule, no copies of these issued patents are being submitted. Please charge any necessary fees to the deposit account of Texas Instruments Incorporated, Account No. 20-0668. Charge any additional fee required or credit any overpayment to the same.

Texas Instruments Incorporated
P. O. Box 655474, M/S 3999
Dallas, Texas 75265
(972) 917-5355

Respectfully submitted,

Yingsheng Tung
Attorney for Applicant(s)
Reg. No. 52,305

